



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

#4
USA
1/24/02

In re PATENT APPLICATION of

Seung-pil Chung et al.

Group Art Unit: 1765

Serial No.: 09/689,814

Examiner: Tran, Binh X

Filed: October 13, 2000

For: METHOD FOR REMOVING OXIDE LAYER AND SEMICONDUCTOR
MANUFACTURING APPARATUS FOR REMOVING OXIDE LAYER

RESPONSE TO ELECTION/RESTRICTION REQUIREMENT

Honorable Commissioner of
Patents and Trademarks,
Washington, D.C. 20231

Sir:

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JAN 28 2002
TC 1700

In response to the Office Action of December 20, 2001, Applicants elect the
invention of Group II, Claims 7-11, 23-29, drawn to apparatus. The election is without
traverse.

Respectfully submitted,

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Dated: January 18, 2002